

Notice of References Cited	Application/Control No. 10/521,733	Applicant(s)/Patent Under Reexamination FUJISAWA ET AL.	
	Examiner David Buttner	Art Unit 1712	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,451,964	09-2002	Hakamaya et al.	528/480
*	B	US-2002/0035206	03-2002	Kurasawa et al.	525/132
	C	US-			
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	F	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

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	N	JP-11080535	03-1999	JP	Saga	---
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NON-PATENT DOCUMENTS

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	U	Kroschwitz, Concise Encyclopedia of Polymer Science and Engineering, 1990; page 870.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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